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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO	
10/604,133	06/27/2003	Masuhiro Natsuhara	39.017-AG	1132	
29453	7590 06/29/2005		EXAMINER		
JUDGE PATENT FIRM RIVIERE SHUKUGAWA 3RD FL.			KACKAR, RAM N		
3-1 WAKAM		ART UNIT	PAPER NUMBER		
	A-SHI, HYOGO, 662-	2-0035	1763		
JAPAN			DATE MAILED: 06/29/2005	5	

Please find below and/or attached an Office communication concerning this application or proceeding.

				NU-1
		Application No.	Applicant(s)	
	Office Action Comments	10/604,133	NATSUHARA ET AL.	
	Office Action Summary	Examiner	Art Unit	
		Ram N. Kackar	1763	
Period fo	The MAILING DATE of this communica or Reply	tion appears on the cover sheet wi	th the correspondence address	
THE - Exte after - If the - If NC - Failt Any	IORTENED STATUTORY PERIOD FOR MAILING DATE OF THIS COMMUNICAL consists of time may be available under the provisions of 3 of SIX (6) MONTHS from the mailing date of this communical construction of the period for reply specified above, the maximum statute under the provision of	ATION. FOR 1.136(a). In no event, however, may a recation. ays, a reply within the statutory minimum of thirty bry period will apply and will expire SIX (6) MON, by statute, cause the application to become AB	eply be timely filed y (30) days will be considered timely. THS from the mailing date of this communicatio ANDONED (35 U.S.C. § 133).	on.
Status				
1)[🖂	Responsive to communication(s) filed of	on <u>27 June 2003</u> .	•	
2a)□	• • • • • • • • • • • • • • • • • • • •	☐ This action is non-final.	•	
3)□	Since this application is in condition for	allowance except for formal matte	ers, prosecution as to the merits is	s
	closed in accordance with the practice	under Ex parte Quayle, 1935 C.D	. 11, 453 O.G. 213.	
Disposit	ion of Claims			
4)🖂	Claim(s) 1-4 is/are pending in the appli	cation.		
	4a) Of the above claim(s) is/are	withdrawn from consideration.		
5)□	Claim(s) is/are allowed.		•	
6)⊠	Claim(s) 1-4 is/are rejected.			
7)	Claim(s) is/are objected to.			
8)	Claim(s) are subject to restrictio	n and/or election requirement.		
Applicat	ion Papers			
9)[The specification is objected to by the E	xaminer.		
10)	The drawing(s) filed on is/are: a)□ accepted or b)□ objected to I	by the Examiner.	
	Applicant may not request that any objection	n to the drawing(s) be held in abeyan	ce. See 37 CFR 1.85(a).	
	Replacement drawing sheet(s) including the		•	d).
11)	The oath or declaration is objected to by	y the Examiner. Note the attached	Office Action or form PTO-152.	
Priority (under 35 U.S.C. § 119			
	Acknowledgment is made of a claim for ☑ All b) ☐ Some * c) ☐ None of:	foreign priority under 35 U.S.C. §	119(a)-(d) or (f).	
	1. Certified copies of the priority do			
	2. Certified copies of the priority do		-	
	3. Copies of the certified copies of t		received in this National Stage	
* 0	application from the International	• • • • • • • • • • • • • • • • • • • •		
	See the attached detailed Office action for	or a list of the centified copies not i	eceivea.	
0.				
Attachmen	• •			
	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-	4) Interview S	ummary (PTO-413))/Mail Date	
	e of Draftsperson's Patent Drawing Review (PTO- mation Disclosure Statement(s) (PTO-1449 or PTO	D/SB/08) 5) D Notice of In	formal Patent Application (PTO-152)	
Pape	r No(s)/Mail Date <u>8/6/2003</u> .	6) Other:	<u>-</u> ·	
C C-1117				

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DETAILED ACTION

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 1-4 are rejected under 35 U.S.C. 103(a) as being unpatentable over Araki et al (US 6239402) in view of Soma et al (US 5231690).

Araki et al disclose an Aluminum Nitride based wafer holder for semiconductor manufacturing device (Fig 8) with a shaft (28) or wafer holder (Fig 9) with a shaft (34) and an electrical circuit formed inside (7 for resistive heating and 9 for plasma) and electrodes for supplying power (12, 13 and 14). The heat capacity of the electrodes could be fairly estimated to be less than 2 J/gK, since compared to the claimed invention the wire (electrodes) number is 3 and length less than 40mm.

This estimation depends upon the typical diameter of power supplying electrodes being 4mm. Typical diameter as taught by Soma et al is 2mm (Col 6 lines 7-10). It may be fairly estimated that even if the diameter is several times that of Soma et al the heat capacity of electrodes will not be more than 5 J/gK.

The heat capacity of the wafer holder however could be fairly estimated to be more than 350 J/gK for wafer holder of Fig 9 and much larger for the wafer holder of Fig 8. Therefore the heat capacity of the electrodes of the disclosed wafer holder would be much less than 10%.

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Conclusion

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ram N. Kackar whose telephone number is 571 272 1436. The examiner can normally be reached on M-F 8:00 A.M to 5:P.M.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on 571 272 1435. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Ray

AU 1763

Ram Kackar